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PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q75721

Koichi TERASHIMA

Appln. No.: 10/644,812

Group Art Unit: 2815

Confirmation No.: 6181

Examiner: Matthew C. LANDAU

Filed: August 21, 2003

For: SEMICONDUCTOR DEVICE AND SEMICONDUCTOR DEVICE
MANUFACTURING METHOD

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Pursuant to 37 C.F.R. § 1.136, Applicant hereby petitions for an extension of time of one month, extending the time for responding to the Office Action of July 15, 2004 to September 15, 2004.

A check for the statutory fee of \$110.00 is attached. The USPTO is directed and authorized to charge all required fees, except for the Issue Fee and the Publication Fee, to Deposit Account No. 19-4880. Please also credit any overpayments to said Deposit Account. A duplicate copy of this sheet is enclosed.

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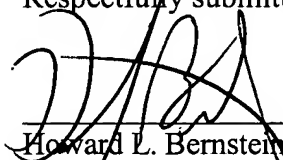
WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: August 24, 2004

Respectfully submitted,


Howard L. Bernstein
Registration No. 25,665